FEB 9, 8 2006 Express Mail No. EV758929076US

Attorney Docket No. 108298404US2 Disclosure No. 99-0319.02/US

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AMENDMENT TRANSMITTAL LETTER					Docket No. 108298404US2
Application No. 10/772,541-Conf. #8900		Filing Date February 5, 2004		Examiner Y. T. Tadess	Art Unit se 1734
,		rebluary 5, 2004		1. 1. Taues	1734
Applicant(s): Agarwal et al.					
nvention: APPARATUS FOR FORMING A PLANARIZING PAD FOR PLANARIZATION OF MICROELECTRONIC SUBSTRATES					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED Claims Highest					
	Remaining After Amendment	Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	15	- 20 =	0	х	
Independent Claims	6	- 4 =	2	x 200.00	400.00
Multiple Dependent Claims (check if applicable)					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					400.00
x Large Entity Small Entity					
No additional fee is required for this amendment.					
Please charge Deposit Account No. 50-0665 in the amount of \$  A duplicate copy of this sheet is enclosed.					
X A check in the amount of \$ 400.00 to cover the filing fee is enclosed.					
Payment by credit card. Form PTO-2038 is attached.					
The Director is hereby authorized to charge and credit Deposit Account No50-0665 as described below. A duplicate copy of this sheet is enclosed.					
x Credit any overpayment.					
x Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
Dated: February 28, 2006					
Chen Liang Attorney/Agent Reg. No.: 51,945					
PERKINS COIE P.O. Box 1247 Seattle, Washir (206) 359-8000	ngton 98111-1	247			

Express Mail No. EV758929076US

## RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE – Art Unit 1734

Attorney Docket No. 108298404US2 Disclosure No. 99-0319.02/US

## **PATENT**



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

VISHNU K. AGARWAL AND

DINESH CHOPRA

**APPLICATION NO.:** 

10/772,541

FILED:

FEBRUARY 5, 2004

For:

APPARATUSES FOR FORMING A

PLANARIZING PAD FOR PLANARIZATION OF

MICROELECTRONIC SUBSTRATES

EXAMINER:

YEWEBDAR T.

**TADESSE** 

**ART UNIT:** 

1734

CONF. NO:

8900

## Amendment Under 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated November 29, 2005 in the above-identified application. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2.

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